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Application No.	Applicant(s)	
10/036,729	MIDDELDORP ET AL	
Examiner	Art Unit	
Young J. Kim	1637	

SEARCHED				
Subclass	Date	Examiner		
6	12/22/2004	YJK		
91.1	12/22/2004	YJK		
91.12	12/22/2004	YJK		
23.1	12/22/2004	YJK		
24.33	12/22/2004	YJK		
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	91.1 91.12 23.1	Subclass Date 6 12/22/2004 91.1 12/22/2004 91.12 12/22/2004 23.1 12/22/2004		

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
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SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
Patent Database (USPT, USPGP, EPO, JPO, DERWENT, IBM-TDB)	12/22/2004	YJK
SEQ ID NO; 1 and 3	12/22/2004	YJK
See enclosed for search strategies.	12/22/2004	YJK
Consulted John LeGuyader on Written Description	12/22/2004	YJK
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